Form PTO 14	49	U.S. DEPARTMENT OF COMMERCE		ATTY DOCKET NO.		SERIAL NO.	
(Modified)		PATENT AND TRADEMARK OFFICE		206169US99		09/766,046	
LIST OF REFERENCES SITED BY APPLICANT				APPLICANT			
LIST	OF REFE	RENCES FITED BY AP	PLICANT	Jamal RAMDANI, et al.			
(SEP. 2: 4: 2004 💆				FILING DATE		GROUP	
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M/.		DOCUMENT NUMBER	DATE	COUNTRY CA	b John S	YES	TRANSLATION NO
11111	CCS	WO 99/67882	12/29/99	WIPO	<u>, () </u>		
1	CC1	WO 95/02904	01/26/95	WIPO	00		
1	CCL	WO 02/009150	01/31/02	WIPO			
1	CC\	0 766 292	04/02/97	EUROPE			
	CCV	/ 198 29 609	01/05/00	GERMANY	$\overline{}$		
	CC>	1 069 605	01/17/01	EUROPE			
N	CCY	0 828 287	03/11/98	EUROPE			
7	CCZ	1 176 230	01/30/02	EUROPE			
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	LL		$\overline{}$	Additional References sheet(s) attached			
Examiner Date Considered 10/30/04							0/30/04
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							